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Tech ID: 23439



ADDITIONAL TECHNOLOGIES BY THESE INVENTORS

- ▶ Space Confined Polymer-Based Field Effect Transistors
- ▶ Novel Metal Chalcogenides For Pseudocapacitive Applications
- ▶ Robust Mesoporous Nife-Based Catalysts For Energy Applications
- ▶ Nanoporous Tin Powder For Energy Applications

Gateway to Innovation, Research and Entrepreneurship

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